

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Masaru MITSUI et al.

Application No.: 09/509,472

Filed: April 21, 2000

Docket No.: 105875

For: PHOTOMASK BLANK, PHOTOMASK, METHODS OF MANUFACTURING
THE SAME AN METHOD OF FORMING MICROPATTERN

SUBMISSION OF ORIGINAL DECLARATION

Director of the U.S. Patent and Trademark Office
Washington, D.C. 20231

Sir:

Submitted herewith is the original signed Declaration of the Inventor. This
Declaration corresponds to the facsimile copy of the Declaration filed on April 21, 2000.

Respectfully submitted,



James A. Oliff
Registration No. 27,075

James A. Oliff
Registration No. 30,411

Date: May 19, 2000

OLIFF & BERRIDGE, PLC
P.O. Box 19928
Alexandria, Virginia 22320
Telephone: (703) 836-6400